



Attorney Docket no: SEL 299

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#8 / Supp
IDS
5-29-03
Article

In re Application of:

Takashi Hamada et al.

Serial No.: 10/051,064

Filed: January 18, 2002

Art Unit: 2823

Examiner: F. Toledo

For: Semiconductor Device and Method
of Manufacturing the Same

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
the Commissioner for Patents, Washington, D.C. 20231
on March 7, 2003

Debra Howe

Debra Howe
Signature

3-7-03
Date

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicants hereby call the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. A copy of each of the documents is enclosed herewith for the Examiner's consideration.

No inference should be drawn that any apparatus disclosed is equivalent to the subject invention.

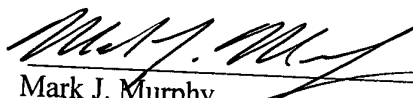
The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

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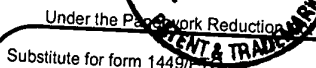
Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

Applicants do not believe that a fee is due since the Office Action mailed on January 21, 2002 was strictly in regards to an election requirement and not on the merits. In addition, a Notice of Allowance or issue fee notification has not been received in this case. However, if any such fee is required, please charge our Deposit Account No. 50/1039.

Respectfully submitted,


Mark J. Murphy
Registration No. 34,225

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(Use as many sheets as necessary)

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| Sheet | 1 | of | 1 |
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Complete if Known

| | |
|------------------------|----------------------|
| Application Number | 10/051,064 |
| Filing Date | January 18, 2002 |
| First Named Inventor | Takashi Hamada et al |
| Art Unit | 2823 |
| Examiner Name | Toledo, Fernando L |
| Attorney Docket Number | SEL 299 |

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS
 Include name of the author (in CAPITAL LETTERS), title, and date of publication.

| OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS | | | |
|---|--------------------------|---|----------------|
| Examiner Initials* | Cite No. ¹ | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T ² |
| | | JONES et al., Boron Diffusion upon Annealing of Laser Thermal Processed..., IEEE, 2000, pp.111-114 ✓ | |
| | | LLEWELLYN et al., Implantation and Annealing of Cu in InP for Electrical..., IEEE, 1997, pp. 313-316 ✓ | |
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 120 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.